



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: Application of: SINGH et al.

Appln No.: 10/082,010

Examiner: Umez Eronini, Lynette T.

Date Filed: February 22, 2002

Group: 1765

For: SLURRY AND METHOD FOR CHEMICAL MECHANICAL POLISHING  
OF METAL STRUCTURES INCLUDING REFRACTORY METAL  
BASED BARRIER LAYERS

CERTIFICATE UNDER 37 CFR 1.8(a)

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class mail in an envelope addressed to the Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 28, 2005.

Neil R. Jetter Reg. No. 46,803

REPLY TO OFFICE ACTION

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated November 29, 2004, a Reply is presented as follows:

A complete Claim listing appears on pages 2-7.

Remarks/Arguments appear on pages 8-12 of this paper.